



03-07-03

1711 \$

Attorney Docket No. UMC-96-279 CON
Client Matter No. 81848.0016.001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:

Chih-Chien LIU, et al.

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA
CHEMICAL VAPOR
DEPOSITION PROCESS

Art Unit: 1711

Examiner: Rabon A. SERGENT

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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned hereby certifies that the attached:

1. Amendment;
2. Petition for 1-Month Extension;
3. Amendment Fee Transmittal;
4. Check for \$470.00;
5. Return postcard,

and this Certificate of Mailing by Express Mail relating to the above application, were deposited as "Express Mail", Mailing Label No. EL533455167US with the United States Postal Service, addressed to: Assistant Commissioner for Patents, Washington, D.C., 20231, on March 6, 2003.

March 6, 2003

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March 6, 2003

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1200 17th Street, Suite 1500
Denver, Colorado 80202
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Continuation application of: Chih-Chien LIU, et al.

Serial No. 09/546,174
Filed April 11, 2000
For HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

THE ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:
Transmitted herewith for filing is an Amendment in the above-identified application.

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	(Col. 1)		(Col. 2)	(Col. 3)
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA
TOTAL	* 44	MINUS	** 24	= 20
INDEP.	* 3	MINUS	*** 3	= 0
16 FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				

SMALL ENTITY

RATE	ADDIT. FEE
x 9 =	\$
x 42 =	\$
+140 =	\$
TOTAL	\$

OR

RATE	ADDIT. FEE
x 18 =	\$ 360.00
x 84 =	\$ 0
+280 =	\$ 0
TOTAL ADDIT. FEE	\$ 360.00

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- ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
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☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

☐ Any patent application processing fees under 37 CFR 1.17.

Dated: March 6, 2003

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#913
3/18/03
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AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed November 6, 2002, please enter the following amendment and consider the remarks that follow.

IN THE CLAIMS:

Please amend claims 50 and 61 according to the attached sheets.

Please add new claims 62-93 according to the attached sheets.

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